Sample Patent Portfolio

Artificial Intelligence Chemistry US 2019/0295169 FRAMEWORK Chemistry US 10,946,356 GAS GENERATOR AND METHOD OF GENERATING GAS US 8,435,581 FOOD AND BEVERAGE EMULSIFIERS HIGH PERFORMANCE ARCHITECTURE WITH SHARED MEMORY US 10,325,208 RELATIONAL MULTI-LEVEL TREE SYSTEMS US 7,080,184 ISDN-BASED BUS INTERFACE Display Technologies US 6,784,009 ELECTRODE PATTERNING IN OLED DEVICES US 10,721,120 INFRASTRUCTURE MANAGEMENT DEVICE Digital Data Processing US 9,672,032 MOBILE ENABLED APPLICATION Equipment US 10,463,553 MAZE TRAINING PLATFORM APPARATUS FOR USE WITH FURNITURE PROTECTING A USER AGAINST INJURIES US 10,378,278 MARI LADDER Manufacturing US 7,269,925 LAYOUT OF PRODUCTION FACILITY AUTOMATED MANUFACTURING SYSTEMS AND METHODS MICRO-ELECTROMECHANICAL DEVICES AND METHODS MICRO-ELECTROMECHANICAL DEVICES AND METHODS SOftware US 10,903,262 DETECTOR US 8,688,616 HIGH-DIMENSIONAL DATA ANALYSIS US 2018/0314977 RISK ANALYSIS EXTENSIBLE EXTRACT, TRANSFORM AND LOAD (ETL) FRAMEWORK SAS GENERATING NANOCRYSTAL LAYERS MAGNETIC MEMORY WITH TUNNELING	Technology	Patent/Publication No.	Title
Chemistry US 10,946,356 GAS GENERATOR AND METHOD OF GENERATING GAS US 8,435,581 FOOD AND BEVERAGE EMULSIFIERS HIGH PERFORMANCE ARCHITECTURE WITH SHARED MEMORY US 10,325,208 RELATIONAL MULTI-LEVEL TREE SYSTEMS US 7,080,184 ISDN-BASED BUS INTERFACE DISplay Technologies US 6,784,009 ELECTRODE PATTERNING IN OLED DEVICES US 10,721,120 INFRASTRUCTURE MANAGEMENT DEVICE Digital Data Processing US 9,483,239 USER INTERFACE DESIGN FRAMEWORK US 9,672,032 MOBILE ENABLED APPLICATION Education US 11,069,250 MAZE TRAINING PLATFORM APPARATUS FOR USE WITH FURNITURE PROTECTING A USER AGAINST INJURIES Manufacturing US 7,269,925 LAYOUT OF PRODUCTION FACILITY AUTOMATED MANUFACTURING SYSTEMS AND METHODS MICRO-ELECTROMECHANICAL DEVICES AND METHODS OF FABRICATING THEREOF MICRO-ELECTROMECHANICAL DEVICES AND METHODS OF FABRICATING THEREOF SCALABLE THERMOELECTRIC-BASED INFRARED DETECTOR SOftware US 8,688,616 HIGH-DIMENSIONAL DATA ANALYSIS US 2018/0314977 RISK ANALYSIS EXTENSIBLE EXTRACT, TRANSFORM AND LOAD (ETL) FRAMEWORK SEMICONDUCTOR US 7,879,673 PATTERNING NANOCRYSTAL LAYERS			INTELLIGENT TRADING AND RISK MANAGEMENT
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Computer Architecture US 7,346,746 WEMORY US 10,325,208 RELATIONAL MULTI-LEVEL TREE SYSTEMS US 7,080,184 Display Technologies US 6,784,009 ELECTRODE PATTERNING IN OLED DEVICES US 10,721,120 Digital Data Processing US 9,483,239 US 9,483,239 US 9,672,032 MOBILE ENABLED APPLICATION Education US 11,069,250 MAZE TRAINING PLATFORM APPARATUS FOR USE WITH FURNITURE PROTECTING A USER AGAINST INJURIES WIS 10,378,278 MAINT LADDER MICRO-ELECTROMECHANICAL DEVICES AND METHODS MICRO-ELECTROMECHANICAL DEVICES AND METHODS OF FABRICATING THEREOF SCALABLE THERMOELECTRIC-BASED INFRARED Systems US 10,903,262 DETECTOR SOFTWARE US 9,560,968 REMOTE MONITORING FRAMEWORK COMPUTING DEVICE FOR MACHINE LEARNING BASED US 2018/0314977 RISK ANALYSIS EXTENSIBLE EXTRACT, TRANSFORM AND LOAD (ETL) FRAMEWORK Semiconductor US 7,879,673 PATTERNING NANOCRYSTAL LAYERS	Chemistry	US 10,946,356	GAS GENERATOR AND METHOD OF GENERATING GAS
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Display Technologies US 6,784,009 ELECTRODE PATTERNING IN OLED DEVICES US 10,721,120 INFRASTRUCTURE MANAGEMENT DEVICE Digital Data Processing US 9,483,239 USER INTERFACE DESIGN FRAMEWORK US 9,672,032 Education US 11,069,250 MAZE TRAINING PLATFORM APPARATUS FOR USE WITH FURNITURE PROTECTING A USER AGAINST INJURIES WS 10,378,278 Manufacturing US 7,269,925 LAYOUT OF PRODUCTION FACILITY AUTOMATED MANUFACTURING SYSTEMS AND METHODS MICRO-ELECTROMECHANICAL DEVICES AND METHODS OF FABRICATING THEREOF Micro- electromechanical Systems US 10,903,262 Software US 8,688,616 HIGH-DIMENSIONAL DATA ANALYSIS US 2018/0314977 RISK ANALYSIS EXTENSIBLE EXTRACT, TRANSFORM AND LOAD (ETL) FRAMEWORK Semiconductor US 7,879,673 PATTERNING NANOCRYSTAL LAYERS		US 10,325,208	RELATIONAL MULTI-LEVEL TREE SYSTEMS
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	Semiconductor	US 7,879,673	
LIG 0 OTG 4G2		115 0 076 463	
US 9,876,163 MAGNETORESISTANCE ENHANCED SPACER LAYER			
US 10,876,975 SYSTEM AND METHOD FOR INSPECTING A WAFER		US 10,876,975	
CHEMICAL MECHANICAL POLISHING (CMP)			, ,
POLISHING HEAD WITH IMPROVED VACUUM US 2021/0094146 SEALING		US 2021/0004146	
PACKAGING METHOD, PANEL ASSEMBLE, WAFER		03 2021/0034140	
US 11,062,917 PACKAGE AND CHIP PACKAGE		US 11 062 917	
ASYMMETRICAL DIGITAL SUBSCRIBER LINE SYSTEM		00 11,002,017	
Telecommunications US 7,486,723 WITH IMPROVED DATA RATE	Telecommunications	US 7.486.723	
US 8,321,442 SEARCHING AND MATCHING OF DATA			